INFORMATION DISCLOSURE CITATION				Docket Number (Optional)	A	pplication Num	ber	^
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				Filing Date Herewith		Group Art Unit Not yet assigned		
EXAMINER	REF	EF DOCUMENT NUMBER DATE		NAME CLASS		SUBCLASS FILING DATE		
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EXAMINER	l· Initial	if citation considered, whether	er or not citation is	in conformance with MPEP 609: draw line th	rough citation if	not in conforma	nce and not o	considered.

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